

METHOD AND SYSTEMS TO CONTROL OPTICAL TRANSMISSIVITY OF A POLISH PAD MATERIAL

ABSTRACT

A method and systems for controlling optical transmissivity of a polish pad material are provided. The method and systems may include adjusting control parameters to determine the optical transmissivity of a polish pad material. The control parameters may also include pre-processing controls, casting controls, and/or curing controls. Methods and systems also provided for assembling a polish pad that controls the optical transmissivity of the polish pad. Additionally, a polish pad with a controlled optical transmissivity is provided.

FIG. 1